

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76836

Katsutoshi MORINAKA, et al.

Appln. No.: 10/566,178

Group Art Unit: 1625

Confirmation No.: 5736

Examiner: Unknown

Filed: January 27, 2006

For: PROCESS FOR PREPARING HIGH-PURITY (METH) ACRYLOYLOXYALKYL
ISOCYANATE

SECOND REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

ATTN: Office of Initial Patent Examination
Filing Receipt Correction
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We enclose a copy of the Corrected Official Filing Receipt for the above-identified application and request the following correction:

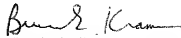
Title

~~PRODUCTION PROCESS OF HIGH PURITY (METH) ACRYLOYLOXYALKYL
ISOCYANATE~~

PROCESS FOR PREPARING HIGH PURITY (METH) ACRYLOYLOXYALKYL
ISOCYANATE

Verification for the requested correction is indicated on the Declaration and Power of Attorney filed January 27, 2006.

Respectfully submitted,



Bruce E. Kramer
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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: January 17, 2007



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
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| APPL NO | FILING OR 371 (c) DATE | ART UNIT | FIL FEE REC'D | ATTY DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS |
|------------|---------------------------|----------|---------------|----------------|----------|----------|----------|
| 10/566,178 | 01/27/2006 | 1625 | 1260 | Q76836 | | 11 | 1 |

CONFIRMATION NO. 5736

CORRECTED FILING RECEIPT



OC00000020613240

23373
 SUGHRUE MION, PLLC
 2100 PENNSYLVANIA AVENUE, N.W.
 SUITE 800
 WASHINGTON, DC 20037

Date Mailed: 09/28/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Katsutoshi Morinaka, Fukushima, JAPAN;
 Kazuyoshi Hoshi, Fukushima, JAPAN;

Assignment For Published Patent Application

SHOWA DENKO K.K., Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 23373.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/11019 07/27/2004
 which claims benefit of 60/493,455 08/08/2003

Foreign Applications

JAPAN 2003-283695 07/31/2003

If Required, Foreign Filing License Granted: 07/15/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/566,178**

Projected Publication Date: 10/26/2006

Non-Publication Request: No

Early Publication Request: No

Title

Production process of high-purity (meth) acryloyloxyalkyl isocyanate
~~PROCESS FOR PREPARING HIGH PURITY (METH) ACRYLOYLOXYALKYL ISOCYANATE~~

Preliminary Class

560

PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

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For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, <http://www.stopfakes.gov>. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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Title 35, United States Code, Section 184

Title 37, Code of Federal Regulations, 5.11 & 5.15

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DECLARATION AND POWER OF ATTORNEY FOR UTILITY OR DESIGN PATENT APPLICATION (37 C.F.R. 1.63)

実用・意匠特許出願宣言書および委任状 (37 C.F.R. 1.63)

Japanese Language Declaration

私は以下の通り宣言します：

I hereby declare that:

各発明者の住所、郵送先、および国籍は下記氏名の後に記載された通りです。

Each inventor's residence, mailing address, and citizenship are as stated below next to their name.

下記名称の発明に関し請求範囲に記載され特許出願がされている発明内容につき、下記に記載された発明者が本発明の最初の発明者であると信じます。

I believe the inventor(s) named below to be the original and first inventor(s) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

Process For Preparing High Purity (Meth)acryloyloxyalkyl

Isocyanate

☐ 上記発明の明細書は本書に添付されます。

☐ the specification of which is attached hereto

または

OR

☐ 上記発明は米国出願番号あるいは PCT 国際出願番号

☒ was filed on July 27, 2004
as United States Application Number or PCT
International Application Number PCT/JP2004/011019
(Confirmation No. _____),
and was amended on _____

(確認番号 _____) として _____
年 ____ 月 ____ 日に出版され、
_____ 年 ____ 月 ____ 日に補正されました (該当
する場合)。

(if applicable).

私は補正が上に明示された場合は補正された特許請求範囲を含む前記明細書の内容を検討し、理解していることをここに表明します。

I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment specifically referred to above.

私は一部継続出願の場合先行出願の出願日から一部継続出願の国内あるいは PCT 国際出願日までの期間中に入手された重要な情報を含み、37 C.F.R. 1.56 に定義される特許性に肝要な情報について開示義務があることを認めます。

I acknowledge the duty to disclose information which is material to patentability as defined in 37 C.F.R. 1.56, including for continuation-in-part application(s), material information which became available between the filing date of the prior application and the national or PCT international filing date of the continuation-in-part application.